

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : TBD
Applicant : Atsuhiro Kawamoto et al.
Filed : Herewith
Title : "ARC WELDING CONTROL METHOD AND ARC
WELDING MACHINE"

Confirmation No. : TBD
TC/A.U. : TBD
Examiner : TBD

International App. No. : PCT/JP2005/011351
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Customer No. : 052054
Docket No. : 39709

INFORMATION DISCLOSURE STATEMENT

Mail Stop PCT
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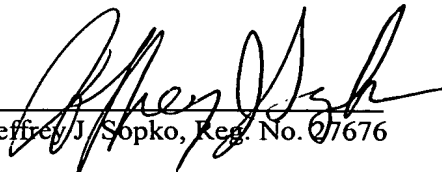
In accordance with Rule 56, applicants are aware of the publications listed in the International Search Report (ISR, copy enclosed) and in the enclosed copy of Patent Office Form 1449. Copies of the publications cited in the International Search Report are not enclosed as they were previously forwarded by the International Bureau, however, a copy of the publication cited in the specification is enclosed.

If there are any fees required by this communication, please charge such fees to our Deposit Account No. 16-0820, Order No. 39709.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION BY APPLICANT <i>(USE SEVERAL SHEETS IF NECESSARY)</i>		APPLICANT: Atsuhiko Kawamoto et al.	
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U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date if Appropriate
	A						
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FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L	50-74546	06/1975	JAPAN			Cited on ISR
	M	10-109163	04/1998	JAPAN			Cited in Specification-English Abstract
	N	2000-158132	06/2000	JAPAN			Cited on ISR
	P	2000-2887303	10/2000	JAPAN			Cited on ISR
	Q						

OTHER REFERENCES *(Including Author, Title, Date, Pertinent Pages, Etc.)*

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